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	Application No.	Applicant(s)
	10/808,949	AIGNER ET AL.
Notice of Allowability	Examiner	Art Unit
	A. Dexter Tugbang	3729
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this a or other appropriate communication IGHTS. This application is subject	pplication. If not included on will be mailed in due course. THIS
1.  This communication is responsive to appeal brief filed on .	June 14, 2007 .	
2. The allowed claim(s) is/are 1 and 31-40 (renumbered as 1	-11, respectively).	•
<ol> <li>Acknowledgment is made of a claim for foreign priority una)</li></ol>	e been received. e been received in Application No. cuments have been received in thi of this communication to file a repl	s national stage application from the
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") must</li> <li>(a) including changes required by the Notice of Draftspers</li> <li>1) hereto or 2) to Paper No./Mail Date</li> <li>(b) including changes required by the attached Examiner' Paper No./Mail Date</li> <li>Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the state of the sheet of the state of the sheet of the</li></ol>	son's Patent Drawing Review(PTC . s Amendment / Comment or in the l.84(c)) should be written on the draw	Office action of vings in the front (not the back) of
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT		
Attachment(s)  1. Notice of References Cited (PTO-892)	5. ☐ Notice of Informal	Patent Application
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☑ Interview Summar	
3. X Information Disclosure Statements (PTO/SB/08),		ate <u>attached herein</u> .
Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's Stater 9. □ Other	nent of Reasons for Allowance
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## **EXAMINER'S AMENDMENT**

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Mark Bilak (Reg. No. 47,423) on August 16, 2007.

The application has been amended as follows.

Claims 3 through 30 have been canceled.

In Claim 1, the phrase of "the bottommost layer," (line 7) has been replaced with —a bottommost layer as—; --of the layer stack—has been added after "second piezoelectric layer" (line 11); --of the layer stack—has been added after "third electrically conductive layer" (line 13).

Claim 31 has been amended as follows.

31. (Amended) The method as claimed in claim 1, wherein, before step e), [the] a resonant frequency of at least one of the stacked crystal filters produced is measured and [in case correction of the resonant frequency is required] in a further step, [the] a layer thickness of the third electrical conductive layer is corrected by local etching-away.

In Claim 33, "a layer" (line 2) has been replaced with –another layer--; and "the layer" (line 2) has been replaced with –the another layer--.

In Claim 34, "an electrically" (lines 1-2) has been replaced with -the electrically--

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In Claim 35, "the layer stack" (line 1) has been replaced with –the another layer stack--.

In Claim 40, "the central" (line 2) has been replaced with –a central--; "the wavelength" (line 4) has been replaced with –a wavelength--; and "the mechanical" (line 4) has been replaced with –a mechanical--.

## Reasons for Allowance

2. The following is an examiner's statement of reasons for allowance.

The prior art does not teach all of the limitations of the claimed invention (as recited in Claim 1 in its entirety) including producing at least a first opening in the third electrically conductive layer and the second electrically layer of the layer stack to provide a contact hole for the second electrically conductive layer, and producing a second openings in at least the third electrically conductive layer of the layer stack in such a way that at least two stacked crystal filters are produced (emphasis added).

In the Final Rejection (mailed on July 27, 2005), the examiner relied upon Seipler et al for the teachings of the above feature. While Seipler does teach forming a first opening in the third electrically conductive layer and second openings in the third electrically conductive layer, these openings are formed prior to, or before, applying a layer stack on a substrate that includes at least the second and third electrically conductive layers. As shown in Figure 1 of Seipler, and discussed at col. 2, lines 59+, the first opening and second openings are formed in each individual conductive layer before they are each assembled in a layer stack. Therefore, Seipler does not teach that step d (lines 10-15 of Claim 1) specifically occurs after step c (lines 6-9 of Claim 1).

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Furthermore, it would not be obvious to modify Seipler by having step d occur after step c, because to do so would destroy the structure of Seipler, thus, destroying the invention of Seipler.

Accordingly, Claim 1 and 31 through 40 are allowed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to A. Dexter Tugbang whose telephone number is 571-272-4570. The examiner can normally be reached on Monday - Friday 7:30 am - 4:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Peter Vo can be reached on 571-272-4690. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

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/A. Dexter Tugbang/ Primary Examiner Art Unit 3729

August 17, 2007